

WHAT IS CLAIMED IS:

1. A multi-beam scanning optical system comprising incidence optical means for guiding a plurality of beams emitted from light source means having a plurality of light-emitting regions spaced apart from each other in a main scanning direction, to deflecting means; scanning optical means for focusing the plurality of beams deflected by the deflecting means, on a surface to be scanned, to form a plurality of scan lines; and synchronism-detecting optical means for converging part of the plurality of beams deflected by the deflecting means, on a slit surface by a lens section, thereafter guiding the beams to a synchronism detector, and controlling timing of a scan start position on the surface to be scanned for each of the plurality of beams by use of a signal from the synchronism detector,

wherein the following condition is satisfied:

$$|\delta M1| \leq \delta Y_{\max} / \tan(\theta_{\max})$$

(where

$\delta M1$: defocus amount in a main scanning section of the beams guided to the synchronism detector and in a view from the slit;

δY_{\max} : permissible dot shift amount per scan line;

θ_{\max} : maximum angle difference between angles of incidence to the slit surface of the beams used for detection of synchronism).

2. The multi-beam scanning optical system according to Claim 1, wherein said permissible dot shift amount per scan line is not more than half of resolution in a sub-scanning direction.

5

3. The multi-beam scanning optical system according to Claim 1, comprising correction means for relatively shifting a focus position in the main scanning section of the beams guided to said
10 synchronism detector in a direction of the optical axis of said synchronism-detecting optical means from said slit surface.

4. The multi-beam scanning optical system
15 according to Claim 1, comprising correction means for moving the position of said slit surface or a unit including the slit surface in a direction of the optical axis of said synchronism-detecting optical means.

20

5. The multi-beam scanning optical system according to Claim 1, wherein said lens section is disposed in an optical path between said deflecting means and said slit surface, said optical system
25 comprising correction means for moving said lens section in a direction of the optical axis of said synchronism-detecting optical means.

6. The multi-beam scanning optical system according to Claim 1, wherein at least one lens forming said lens section is integrated with said scanning optical means, said optical system comprising
5 correction means for moving at least one lens of the lens section not integrated with the scanning optical means, and said slit surface in a direction of the optical axis of said synchronism-detecting optical means.

10

7. The multi-beam scanning optical system according to Claim 1, wherein said lens section is integrated with said scanning optical means, said optical system comprising correction means for moving
15 at least one optical element of the scanning optical means in a direction of the optical axis of the scanning optical means and for moving said slit surface in a direction of the optical axis of said synchronism-detecting optical means.

20

8. The multi-beam scanning optical system according to Claim 1, wherein at least one lens forming said lens section is integrated with said scanning optical means, said optical system comprising
25 correction means for moving at least one lens forming the scanning optical means in the main scanning direction.

9. A multi-beam scanning optical system comprising incidence optical means for guiding a plurality of beams emitted from light source means having a plurality of light-emitting regions spaced
5 apart from each other in a main scanning direction, to deflecting means; scanning optical means for focusing the plurality of beams deflected by the deflecting means, on a surface to be scanned, to form a plurality of scan lines; and synchronism-detecting optical means
10 for converging part of the plurality of beams deflected by the deflecting means, on a slit surface by a lens section, thereafter guiding the beams to a synchronism detector, and controlling timing of a scan start position on the surface to be scanned for each of the
15 plurality of beams by use of a signal from the synchronism detector,

said multi-beam scanning optical system comprising correction means for correcting a dot shift per scan line on the surface to be scanned, which occurs because
20 of a defocus amount $\delta M1$ in a main scanning section of the beams guided to the synchronism detector and in a view from the slit surface.

10. The multi-beam scanning optical system
25 according to Claim 9, wherein said dot shift is not more than half of resolution in a sub-scanning direction.

11. The multi-beam scanning optical system according to Claim 9, wherein said plurality of light-emitting regions are spaced apart from each other in the main scanning direction and in the sub-scanning direction.

12. The multi-beam scanning optical system according to Claim 11, wherein a slit in said slit surface is inclined in the sub-scanning direction according to the dot shift per scan line on said surface to be scanned.

13. The multi-beam scanning optical system according to Claim 11, comprising rotating means for rotating said slit surface or a unit including the slit surface about the optical axis of the synchronism-detecting optical means according to the dot shift per scan line on said surface to be scanned.

14. A multi-beam scanning optical system comprising incidence optical means for guiding a plurality of beams emitted from light source means having a plurality of light-emitting regions spaced apart from each other in a main scanning direction, to deflecting means; scanning optical means for focusing the plurality of beams deflected by the deflecting means on a surface to be scanned, to form a plurality

of scan lines; and synchronism-detecting optical means for guiding part of the plurality of beams deflected by the deflecting means, to a synchronism detector by a lens section and controlling timing of a scan start position on the surface to be scanned for each of the plurality of beams by use of a signal from the synchronism detector,

wherein the following condition is satisfied:

$$|\delta M2| \leq \delta Y_{\max} / \tan(\theta_{\max})$$

(where

$\delta M2$: defocus amount in a main scanning section of the beams guided to the synchronism detector and in a view from a photoreceptive surface of the synchronism detector;

δY_{\max} : permissible dot shift amount per scan line;

θ_{\max} : maximum angle difference between angles of incidence to the photoreceptive surface of the beams used for detection of synchronism).

15. The multi-beam scanning optical system according to Claim 14, wherein said permissible dot shift amount per scan line is not more than half of resolution in a sub-scanning direction.

16. The multi-beam scanning optical system according to Claim 14, comprising correction means for relatively shifting a focus position in the main

scanning section of the beams guided to said
synchronism detector in a direction of the optical axis
of said synchronism-detecting optical means from the
photoreceptive surface of the synchronism detector.

5

17. The multi-beam scanning optical system
according to Claim 14, comprising correction means for
moving the position of said synchronism detector or a
unit including the synchronism detector in a direction
10 of the optical axis of said synchronism-detecting
optical means.

18. The multi-beam scanning optical system
according to Claim 14, wherein said lens section is
15 disposed in an optical path between said deflecting
means and said synchronism detector, said optical
system comprising correction means for moving said lens
section in a direction of the optical axis of said
synchronism-detecting optical means.

20

19. The multi-beam scanning optical system
according to Claim 14, wherein at least one lens
forming said lens section is integrated with said
scanning optical means, said optical system comprising
25 correction means for moving at least one lens of the
lens section not integrated with the scanning optical
means, and said synchronism detector in a direction of

the optical axis of said synchronism-detecting optical means.

20. The multi-beam scanning optical system
5 according to Claim 14, wherein said lens section is
integrated with said scanning optical means, said
optical system comprising correction means for moving
at least one optical element of the scanning optical
means in a direction of the optical axis of the
10 scanning optical means and for moving said synchronism
detector in a direction of the optical axis of said
synchronism-detecting optical means.

21. The multi-beam scanning optical system
15 according to Claim 14, wherein at least one lens
forming said lens section is integrated with said
scanning optical means, said optical system comprising
correction means for moving at least one lens forming
the scanning optical means in the main scanning
20 direction.

22. A multi-beam scanning optical system
comprising incidence optical means for guiding a
plurality of beams emitted from light source means
25 having a plurality of light-emitting regions spaced
apart from each other in a main scanning direction, to
deflecting means; scanning optical means for focusing

the plurality of beams deflected by the deflecting means, on a surface to be scanned; and synchronism-detecting optical means for converging part of the plurality of beams deflected by the deflecting means,
5 on a slit surface by a lens section, thereafter guiding the beams to a synchronism detector, and controlling timing of a scan start position on the surface to be scanned by use of a signal from the synchronism detector,

10 wherein, where $\delta M1$ is a defocus amount in a main scanning section of the beams guided to the synchronism detector and in a view from the slit surface and δX is a defocus amount at each image height on the surface to be scanned, the following condition is satisfied:

15
$$|\delta X - \delta M1| \leq \delta Y_{\max} / \theta_{\max}$$

(where

δY_{\max} : permissible dot shift amount per scan line;

θ_{\max} : maximum angle difference between angles of incidence to the slit surface of the beams used for
20 detection of synchronism).

23. The multi-beam scanning optical system according to Claim 22, wherein said permissible dot shift amount per scan line is not more than half of
25 resolution in a sub-scanning direction.

24. The multi-beam scanning optical system

according to Claim 22, comprising correction means for relatively shifting a focus position in the main scanning section of the beams guided to said synchronism detector in a direction of the optical axis of said synchronism-detecting optical means from said slit surface.

25. The multi-beam scanning optical system according to Claim 22, comprising correction means for moving the position of said slit surface or a unit including the slit surface in a direction of the optical axis of said synchronism-detecting optical means.

26. The multi-beam scanning optical system according to Claim 22, wherein said lens section is disposed in an optical path between said deflecting means and said slit surface, said optical system comprising correction means for moving said lens section in a direction of the optical axis of said synchronism-detecting optical means.

27. A multi-beam scanning optical system comprising incidence optical means for guiding a plurality of beams emitted from light source means having a plurality of light-emitting regions spaced apart from each other in a main scanning direction, to

deflecting means; scanning optical means for focusing
the plurality of beams deflected by the deflecting
means, on a surface to be scanned, to form a plurality
of scan lines; and synchronism-detecting optical means
5 for converging part of the plurality of beams deflected
by the deflecting means, on a slit surface by a lens
section, thereafter guiding the beams to a synchronism
detector, and controlling timing of a scan start
position on the surface to be scanned for each of the
10 plurality of beams by use of a signal from the
synchronism detector;

where $\delta M1$ is a defocus amount in a main scanning
section of the beams guided to the synchronism detector
and in a view from the slit surface and δX is a defocus
15 amount at each image height on the surface to be
scanned, said multi-beam scanning optical system
comprising correction means for correcting a dot shift
per scan line on the surface to be scanned, which
occurs because of a difference between the two defocus
20 amounts $\delta M1$, δX .

28. The multi-beam scanning optical system
according to Claim 27, wherein said dot shift is not
more than half of resolution in a sub-scanning
25 direction.

29. The multi-beam scanning optical system

according to Claim 27, wherein said plurality of light-emitting regions are spaced apart from each other in the main scanning direction and in the sub-scanning direction.

5

30. The multi-beam scanning optical system according to Claim 29, wherein a slit in said slit surface is inclined in the sub-scanning direction according to the dot shift per scan line on said surface to be scanned.

10

31. The multi-beam scanning optical system according to Claim 29, comprising rotating means for rotating said slit surface or a unit including the slit surface about the optical axis of the synchronism-detecting optical means according to the dot shift per scan line on said surface to be scanned.

15

32. A multi-beam scanning optical system comprising incidence optical means for guiding a plurality of beams emitted from light source means having a plurality of light-emitting regions spaced apart from each other in a main scanning direction, to deflecting means; scanning optical means for focusing the plurality of beams deflected by the deflecting means on a surface to be scanned; and synchronism-detecting optical means for guiding part of the

20

25

plurality of beams deflected by the deflecting means,
to a synchronism detector by a lens section and
controlling timing of a scan start position on the
surface to be scanned by use of a signal from the
5 synchronism detector,

wherein, where $\delta M2$ is a defocus amount in a main
scanning section of the beams guided to the synchronism
detector and in a view from a photoreceptive surface of
said synchronism detector and δX is a defocus amount at
10 each image height on the surface to be scanned, the
following condition is satisfied:

$$|\delta X - \delta M2| \leq \delta Y_{\max} / \theta_{\max}$$

(where

δY_{\max} : permissible dot shift amount per scan line;
15 θ_{\max} : maximum angle difference between angles of
incidence to the photoreceptive surface of the beams
used for detection of synchronism).

33. The multi-beam scanning optical system
20 according to Claim 32, wherein said permissible dot
shift amount per scan line is not more than half of
resolution in a sub-scanning direction.

34. The multi-beam scanning optical system
25 according to Claim 32, comprising correction means for
relatively shifting a focus position in the main
scanning direction of the beams guided to said

synchronism detector in a direction of the optical axis of said synchronism-detecting optical means from the photoreceptive surface of the synchronism detector.

5 35. The multi-beam scanning optical system according to Claim 32, comprising correction means for moving the position of said synchronism detector or a unit including the synchronism detector in a direction of the optical axis of said synchronism-detecting
10 optical means.

 36. The multi-beam scanning optical system according to Claim 32, wherein said lens section is disposed in an optical path between said deflecting
15 means and said synchronism detector, said optical system comprising correction means for moving said lens section in a direction of the optical axis of said synchronism-detecting optical means.

20 37. An image forming apparatus comprising the multi-beam scanning optical system as set forth in either one of Claims 1 to 36; a photosensitive member placed on said surface to be scanned; a developing unit for developing an electrostatic latent image formed on
25 said photosensitive member with scanning light by said multi-beam scanning optical system, into a toner image; a transfer unit for transferring said developed toner

image onto a transfer medium; and a fixing unit for fixing the transferred toner image on the transfer medium.

5 38. An image forming apparatus comprising the multi-beam scanning optical system as set forth in either one of Claims 1 to 37; and a printer controller for converting code data supplied from an external device, into an image signal and entering the image
10 signal into said multi-beam scanning optical system.

 39. A multi-beam scanning optical system comprising incidence optical means for guiding a plurality of beams emitted from light source means
15 having a plurality of light-emitting regions spaced apart from each other in a main scanning direction, to deflecting means; scanning optical means for focusing the plurality of beams deflected by the deflecting means, on a surface to be scanned, to form a plurality
20 of scan lines; and synchronism-detecting optical means for converging part of the plurality of beams deflected by the deflecting means, on a slit surface by a lens section, thereafter guiding the beams to a synchronism detector, and controlling timing of a scan start
25 position on the surface to be scanned for each of the plurality of beams by use of a signal from the synchronism detector,

wherein a dot shift per scan line on the surface to be scanned, which occurs because of a defocus amount $\delta M1$ in a main scanning section of the beams guided to said synchronism detector and in a view from said slit surface, is not more than half of resolution in a sub-scanning direction.

40. A multi-beam scanning optical system comprising incidence optical means for guiding a plurality of beams emitted from light source means having a plurality of light-emitting regions spaced apart from each other in a main scanning direction, to deflecting means; scanning optical means for focusing the plurality of beams deflected by the deflecting means, on a surface to be scanned, to form a plurality of scan lines; and synchronism-detecting optical means for guiding part of the plurality of beams deflected by the deflecting means, to a synchronism detector by a lens section and controlling timing of a scan start position on the surface to be scanned for each of the plurality of beams by use of a signal from the synchronism detector,

wherein a dot shift per scan line on the surface to be scanned, which occurs because of a defocus amount $\delta M2$ in a main scanning section of the beams guided to said synchronism detector and in a view from a photoreceptive surface of said synchronism detector, is

not more than half of resolution in a sub-scanning direction.

41. A multi-beam scanning optical system
5 comprising incidence optical means for guiding a plurality of beams emitted from light source means having a plurality of light-emitting regions spaced apart from each other in a main scanning direction, to deflecting means; scanning optical means for focusing
10 the plurality of beams deflected by the deflecting means, on a surface to be scanned, to form a plurality of scan lines; and synchronism-detecting optical means for converging part of the plurality of beams deflected by the deflecting means, on a slit surface by a lens
15 section, thereafter guiding the beams to a synchronism detector, and controlling timing of a scan start position on the surface to be scanned for each of the plurality of beams by use of a signal from the synchronism detector,
20 wherein, where δM_1 is a defocus amount in a main scanning section of the beams guided to said synchronism detector and in a view from said slit surface and δX is a defocus amount at each image height on said surface to be scanned, a dot shift per scan
25 line on the surface to be scanned, which occurs because of a difference between the two defocus amounts δM_1 , δX , is not more than half of resolution in a sub-

scanning direction.

42. A multi-beam scanning optical system comprising incidence optical means for guiding a plurality of beams emitted from light source means having a plurality of light-emitting regions spaced apart from each other in a main scanning direction, to deflecting means; scanning optical means for focusing the plurality of beams deflected by the deflecting means, on a surface to be scanned, to form a plurality of scan lines; and synchronism-detecting optical means for guiding part of the plurality of beams deflected by the deflecting means to a synchronism detector by a lens section and controlling timing of a scan start position on the surface to be scanned for each of the plurality of beams by use of a signal from the synchronism detector,

wherein, where $\delta M2$ is a defocus amount in a main scanning section of the beams guided to said synchronism detector and in a view from a photoreceptive surface of said synchronism detector and δX is a defocus amount at each image height on said surface to be scanned, a dot shift per scan line on the surface to be scanned, which occurs because of a difference between the two defocus amounts $\delta M2$, δX , is not more than half of resolution in a sub-scanning direction.